

PROCEEDINGS OF SPIE

***Emerging Digital Micromirror
Device-based Systems
and Applications XVIII***

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Editors

**19–22 January 2026
San Francisco, California, United States**

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Published by
SPIE

Volume 13918

Proceedings of SPIE 0277-786X, V. 13918

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

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Author(s), "Title of Paper," in *Emerging Digital Micromirror Device-based Systems and Applications XVIII*, edited by Alex Lyubarsky, Karina Bridger, Proc. of SPIE 13918, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510697539

ISBN: 9781510697546 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time)

SPIE.org

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